



PATENT
81877.0012

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiyo Nakashima et al.

Serial No: 09/816,643

Filed: March 23, 2001

For: SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING
METHOD

Art Unit: 1763

Examiner: Kackar, Ram N

I hereby certify that this correspondence
is being deposited with the United States
Postal Service with sufficient postage as
first class mail in an envelope addressed
to:

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on
June 30, 2004

Date of Deposit

Anthony J. Orler, Reg. No. 41,232

Name

Signature

06/30/04

Date

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the
Commissioner for a three-month extension of time extending to June 30, 2004, the
period for response to the Office Action dated December 30, 2003. A check for \$950
is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account
No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By: 

Anthony J. Orler
Registration No. 41,232
Attorney for Applicant(s)

Date: June 30, 2004

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